

Examiner-Initiated Interview Summary	Application No.	Applicant(s)	
	10/802,596	MATONO, NAOTO	

Examiner	Art Unit	
A. Dexter Tugbang	3729	

All Participants:
Status of Application: _____

(1) A. Dexter Tugbang, Examiner. (3) _____.

(2) Sumit Bhattacharya, for Applicant(s). (4) _____.

Date of Interview: 13 August 2009
Time: _____

Type of Interview:

- Telephonic
 Video Conference
 Personal (Copy given to: Applicant Applicant's representative)

Exhibit Shown or Demonstrated: Yes No

If Yes, provide a brief description: .

Part I.

Rejection(s) discussed:

n/a

Claims discussed:

9

Prior art documents discussed:

Japanese Patent Publication JP 63-293712, referred to hereinafter as JP'712
Part II.
SUBSTANCE OF INTERVIEW DESCRIBING THE GENERAL NATURE OF WHAT WAS DISCUSSED:

In light of the IDS filed on July 16, 2009, particularly the reference to JP'712, the examiner urged additional changes to Claim 9 to clearly define the claims over the prior art. Claim 9 was amended to specify the sequence of when the "gap layer", "first magnetic layer", and "trim structure" were formed. The applicant(s) agreed to these changes, as noted in the attached Examiner's amendment, which placed the application in condition for allowance

Part III.

- It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview directly resulted in the allowance of the application. The examiner will provide a written summary of the substance of the interview in the Notice of Allowability.
 It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview did not result in resolution of all issues. A brief summary by the examiner appears in Part II above.

*/A. Dexter Tugbang/
Primary Examiner, Art Unit 3729*
(Applicant/Applicant's Representative Signature – if appropriate)

